



Attorney's Docket No.: 07977/093002/US316401

THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hisashi Ohtani, et al.

Art Unit : 2815

Serial No.: 09/379,702

Examiner : Eugene Lee

Filed : August 24, 1999

Title : METHOD OF FABRICATING SEMICONDUCTOR DEVICES

Commissioner for Patents

Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

Applicants call attention to the enclosed documents listed on the attached form PTO-1449.

Kindly accept this Information Disclosure Statement under Rule 97(c) (1).

The rule 17(p) certification fee of \$180 is enclosed.

The documents are in the English language hence no concise explanation is necessary per rule 97(c).

Consideration of the foregoing and enclosures plus the return of a copy of the enclosed Form PTO-1449 with the Examiner's initials in the left column per MPEP 609 are earnestly solicited along with an early action on the merits.

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, Washington, D.C. 20231.

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Respectfully submitted,

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A. J. Harris 456 no 40,63'  
for Scott C. Harris  
Reg. No. 32,030

SCH/smr

Fish & Richardson P.C.  
PTO Customer No. 20985  
4350 La Jolla Village Drive, Suite 500  
San Diego, CA 92122  
Telephone: (858) 678-5070  
Facsimile: (858) 678-5099

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